



**PATENT APPLICATION**

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Akira SAKAI et al.

Group Art Unit: 2829

Application No.: 10/807,235

Examiner: E. Pert

Filed: March 24, 2004

Docket No.: 119232

For: METHOD FOR FABRICATING A METALLIC OXIDE OF HIGH DIELECTRIC  
CONSTANT, METALLIC OXIDE OF HIGH DIELECTRIC CONSTANT, GATE  
INSULATING FILM AND SEMICONDUCTOR ELEMENT

**SUPPLEMENTAL AMENDMENT**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

As a supplement to the Amendment filed on December 22, 2004, please further  
consider the following:

**Amendments to the Claims** as reflected in the listing of claims; and

**Remarks.**